



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of:

Koichiro TANAKA

Serial No. 10/664,916

Filed: September 22, 2003

For: BEAM HOMOGENIZER AND LASER
IRRADIATION APPARATUS AND
METHOD OF MANUFACTURING
SEMICONDUCTOR DEVICE

) Group Art Unit: 1722

) Examiner: Robert M. Kunemund

) CERTIFICATE OF MAILING
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Alexandria, VA 22313-1450, on November 22,
2006.

) Adrian Stampur

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated August 22, 2006, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 17 of this paper.